

## Jordan University of Science and Technology Faculty of Engineering Biomedical Engineering Department

## BME550 Biomems And Nanotechnology

Second Semester 2023-2024

## **Course Catalog**

3 Credit Hours. Introduction to microfabrication technologies and microfluidic principles and their applications in biomedical microdevices design, fabrication, and packaging.

Teaching Method: On Campus

Text Book											
Title	BioMEMS and Biomedical Nanotechnology										
Author(s)	Ferrari M										
Edition	2nd Edition										
Short Name	BMBN										
Other Information	Springer Publications										

**Course References** 

Short name	Book name	Author(s)	Edition	Other Information
Madou	Fundamentals of Microfabrication: The Science of Miniaturization	MJ Madou	3rd Edition	
Wereley	Fundamentals And Applications Of Microfluidics	Nguyen N.T., Wereley S. T.	3rd Edition	

Instructor								
Name	Prof. Ruba Khnouf							
Office Location	C5 L2							
Office Hours	Sun : 11:30 - 13:30 Mon : 10:00 - 10:30 Tue : 11:30 - 13:30 Thu : 11:30 - 13:30							

Email

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## **Class Schedule & Room**

Section 1:

Lecture Time: Sun, Tue, Thu : 10:30 - 11:30 Room: G2123

Prerequisites									
Line Number Course Name Prerequisit									
284400	BME440 Introduction To Biomedical Materials	Prerequisite / Study							
283420	BME342 Bio Fluid Mechanics	Prerequisite / Pass							

Tentative List of Topics Covered												
Weeks	Weeks Topic											
Week 1	Introduction	From <b>BMBN</b> , From <b>Madou</b> , From <b>Wereley</b>										
Weeks 2, 3	Silicon Microfabrication	From <b>Madou</b>										
Weeks 4, 5	Soft Microfabrication Techniques	From <b>Madou</b>										
	Microfluidic Principles	From Wereley										
Weeks 8, 9	Microfluidic Components	From <b>Madou</b> , From <b>Wereley</b>										
Weeks 10, 11	Clinical Lab Tests	From <b>BMBN</b>										
Weeks 13, 14	Micro Total Anaylsis Systems/ Lab on Chip	From <b>BMBN</b>										

Mapping of Course Outcomes to Program Outcomes	Course Outcome Weight (Out of 100%)	Assessment method
Appreciate the role of miniaturization and microfabrication in engineering	10%	
Study the crystal structure of silicon and glass and the resulting properties of this structure	10%	
Study the mechanisms of silicon microfabrication including lithography methods, etching, methods, wet and dry bulk surface micromachining, electroplating and other thin film deposition techniques, and substrate bonding	20%	
Study soft fabrication methodologies including soft lithography, polymeric surface micromachining, micromolding, and 3D photopolymerization	20%	
Study microfluidic principles	30%	

Apply microfabrication and microfluidic principles on micrototal analysis systems and	10%
lab on chip device design	

	Relationship to Program Student Outcomes (Out of 100%)																		
А	В	С	D	Е	F	G	н	I	J	к	L	М	SLO1	SLO2	SLO3	SLO4	SLO5	SLO6	SLO7

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